DERWENT-

2002-506200

ACC-NO:

DERWENT-

200254

WEEK:

COPYRIGHT 2007 DERWENT INFORMATION LTD

TITLE:

Method to accurately define the decapsulated area of plastic package - by dropping the etching liquid in an automatic transportation manner to remove the

sealed cap portion

INVENTOR: YE, M

PATENT-ASSIGNEE: TAIWAN SEMICONDUCTOR MFG CO LTD[TASEN]

PRIORITY-DATA: 2000TW-0102897 (February 19, 2000)

PATENT-FAMILY:

 PUB-NO
 PUB-DATE
 LANGUAGE
 PAGES
 MAIN-IPC

 TW 463340 A November 11, 2001 N/A
 000 H01L 023/28

APPLICATION-DATA:

PUB-NO APPL-DESCRIPTOR APPL-NO APPL-DATE

TW 463340A N/A

2000TW-0102897 February 19, 2000

INT-CL (IPC): H01L023/28

ABSTRACTED-PUB-NO: TW 463340A

## BASIC-ABSTRACT:

NOVELTY - A method to accurately define the decapsulated area of plastic package is disclosed, wherein a mask with a size larger than that of the plastic package is pasted on the surface of the plastic package. Next, the **decapsulated area is defined in this mask** according to the size and position of the semiconductor chip of the plastic package. Then this plastic package is heated to a specific temperature, and the etching liquid is dropped on the decapsulated area of this plastic package manually, or the etching liquid with a specific temperature is dropped on the decapsulated area of this plastic package in an automatic transportation manner to remove the sealed cap portion of the **decapsulated area** and expose the semiconductor chip. Then the semiconductor chip is cleaned.

CHOSEN- Dwg.1/1

DRAWING:

TITLE-TERMS: METHOD ACCURACY DEFINE AREA PLASTIC PACKAGE DROP ETCH LIQUID AUTOMATIC

TRANSPORT MANNER REMOVE SEAL CAP PORTION

DERWENT-CLASS: L03 U11

CPI-CODES: L04-C07; L04-C20;

3/31/07, EAST Version: 2.0.3.0

EPI-CODES: U11-E02A1;

SECONDARY-ACC-NO:

CPI Secondary Accession Numbers: C2002-143832
Non-CPI Secondary Accession Numbers: N2002-400411

